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***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

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In re application of: Wu et al.

Attorney Docket No.:  
NOVLP094/NVLS-2919

Application No.: 10/789,103

Examiner: Bret P. Chen

Filed: February 27, 2004

Group: 1762

Title: METHODS FOR PRODUCING LOW-  
K CDO FILMS WITH LOW RESIDUAL  
STRESS

Confirmation No: 7687

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CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on November 21, 2007.

Signed: \_\_\_\_\_/Joyce L. Ferreira/  
Joyce L. Ferreira

**AMENDMENT D**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated June 21, 2007 in the above-identified application, please consider the following:

Amendments to the Claims reflected in the **Listing of Claims** that begins on page 2 of this paper.

**Remarks** beginning on page 6 of this paper.